

DOCKET NO: 296428US26PCT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :  
TSUYOSHI TAKAHASHI, ET AL. : EXAMINER: MILLER, JR., J. A.  
SERIAL NO: 10/593,254 :  
FILED: SEPTEMBER 18, 2006 : GROUP ART UNIT: 1792  
FOR: METHOD AND APPARATUS FOR :  
FORMING METAL SILICATE FILM, AND  
METHOD FOR MANUFACTURING  
SEMICONDUCTOR DEVICE

AMENDMENT UNDER 35 U.S.C. § 37 C.F.R. 1.111

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action dated January 21, 2009, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 7 of this paper.